

IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: ASPAR et al.

SERIAL NO.: 10/784,601

FILED: February 23, 2004

FOR: A Method for Producing a Thin Layer of Semiconductor Material

DOCKET: BREV 12370 CON4

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

In connection with the above-entitled matter, Applicants hereby proffer U.S. Patent Office Form PTO-1449, including a copy of the reference listed therein. This reference came to applicants' attention in connection with litigation concerning a related U.S. Patent. The claims in the present application are believed to be patentably distinguished over this reference.

This Supplemental Information Disclosure Statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitutes prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

The enclosed Supplemental Information Disclosure Statement is being submitted prior to issuance of the first action on the merits. Therefore, we believe there are no fees involved with this Information Disclosure Statement. In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

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Serial No. 10/784,601  
Docket No. 12370 CON4  
Supplemental Information Disclosure Statement

Respectfully submitted,



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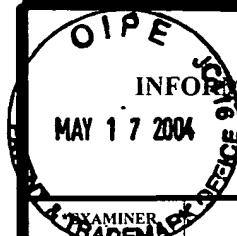
**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 12, 2004 at Tucson, Arizona.

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## INFORMATION DISCLOSURE CITATION

MAY 17 2004

(Use several sheets if necessary)

**Docket Number (Optional)**

BREV 12370 CON4

**Application Number**

10/784,601

**Applicant(s)**

ASPAR et al.

**Filing Date**

February 23, 2004

## Group Art Unit

**OTHER DOCUMENTS** (*Including Author, Title, Date, Pertinent Pages, Etc.*)

"Applications of Ion Beams to Materials, 1975" Carter et al., Inst. Phys. Conf. Ser. No. 28, Chapter 1, 1976, pgs. 30-36

**\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and**